



**PATENT APPLICATION**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of

Docket No: Q80484

Tsukasa YAMANAKA, et al.

Appln. No.: 10/801,723

Group Art Unit: 1752

Confirmation No.: 1889

Examiner: Amanda C. Walke

Filed: March 17, 2004

For: POSITIVE RESIST COMPOSITION AND METHOD OF PATTERN FORMATION USING THE SAME

**AMENDMENT UNDER 37 C.F.R. § 1.111**

**MAIL STOP AMENDMENT**

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

A petition and the required fee are submitted herewith for a one (1) month extension of time to extend the time period for reply to the Office Action dated September 7, 2005 from December 7, 2005 to January 9, 2006 (January 7, 2006, being a Saturday).

Please amend the above-identified application as follows on the accompanying pages.

**TABLE OF CONTENTS**

|                                |   |
|--------------------------------|---|
| AMENDMENTS TO THE CLAIMS ..... | 2 |
| REMARKS.....                   | 7 |